

Electronic Patent Application Fee Transmittal

Application Number:	10784275			
Filing Date:	24-Feb-2004			
Title of Invention:	Plasma processing apparatus and plasma processing method			
First Named Inventor/Applicant Name:	Tsutomu Tetsuka			
Filer:	Melvin Kraus/joy aiken			
Attorney Docket Number:	648.43518X00			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Notice of appeal	1401	1	510	510
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				510